

ABSTRACT OF THE DISCLOSURE

5 A method of manufacturing a structure with pores
which are formed by anodic oxidation and whose layout,
pitch, position, direction, shape and the like can be
controlled. The method includes the steps of:
disposing a lamination film on a substrate, the
lamination film being made of insulating layers and a
layer to be anodically oxidized and containing aluminum
as a main composition; and performing anodic oxidation
10 starting from an end surface of the lamination film to
form a plurality of pores having an axis substantially
parallel to a surface of the substrate, wherein the
layer to be anodically oxidized is sandwiched between
the insulating layers, and a projected pattern
15 substantially parallel to the axis of the pore is
formed on at least one of the insulating layers at
positions between the pores.

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